

IPW



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:
Tzu-Chiang Sung et al.

Confirmation Number: 7583

Serial No.: 10/614,462

Group Art Unit: 2815
Examiner: Landau, Matthew

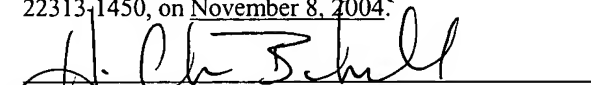
Filed: 07/07/2003

TKHR Docket No. 252011-1490
Top-Team Ref. 0503-9856US

For: HIGH VOLTAGE METAL-OXIDE SEMICONDUCTOR DEVICE

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 8, 2004.


Signature - Hui Chin Barnhill

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop -Amendment
Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The Office Action mailed September 15, 2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.